



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....09/902,277  
Filing Date .....July 9, 2001  
Inventor.....Gurtej S. Sandhu et al.  
Assignee.....Micron Technology, Inc.  
Group Art Unit.....2813  
Examiner ..... Schillinger, Laura M.  
Attorney's Docket No. ....MI22-1780  
Title: Method of Forming a Thin Film Transistor

**RESPONSE TO OCTOBER 21, 2003 FINAL ACTION ACCOMPANYING RCE FILING**

To: Mail Stop RCE  
Commissioner for Patents  
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**AMENDMENTS**

**Introductory Comments**

In reply to the Final Office Action of October 21, 2003, applicant amends and remarks as follows.

